



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/075,193
Filing Date February 13, 2002
Inventor Shenlin Chen et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Huynh, Y.
Attorney's Docket No. MI22-1927
Title: Methods of Forming a Capacitor Structure

**RESPONSE TO DECEMBER 14, 2004 NOTICE OF ALLOWANCE
TO ACCOMPANY RCE FILING**

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AMENDMENTS

Introductory Comments

This response accompanies a petition to withdraw from issue and request for continued examination of the application. Applicant remarks as follows.